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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

The Patent application of:

Applicant(s): Paul A. Kohl et al.

Serial No: 10/647,813

Filing Date: August 25, 2003

Title: FABRICATION OF SEMICONDUCTOR DEVICES WITH AIR GAPS FOR
ULTRA LOW CAPACITANCE INTERCONNECTIONS AND METHODS
OF MAKING SAME

Examiner: Tuan H. Nguyen

Art Unit: 2813

Docket No. PRMSP0285USB

REPLY TO OFFICE ACTION DATED JULY 6, 2004

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Favorable reconsideration of the above-referenced application is respectfully requested in view of the following part(s) of this reply:

Amendments to the Claims
Remarks

Enclosures: ☒ Credit card payment form
☒ Petition for Extension of Time
☒ Information Disclosure Statement

In the event any fee or additional fee is due in connection with the filing of this paper, the Commissioner is authorized to charge those fees to our Deposit Account No. 18-0988 (under the above Docket Number). In the event an extension of time is needed to make the filing of this paper timely and no separate petition is attached, please consider this a petition for the requisite extension and charge the fee to our Deposit Account No. 18-0988 (under the above Docket Number).